



Docket No. FIS920010024US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Basanth Jagannathan, *et al.*

Serial No.: 09/843,783

Confirmation No.: 1078

Filed: April 30, 2001

For: **METHOD TO INCREASE CARBON AND BORON DOPING
CONCENTRATION IN Si AND SiGe FILMS**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Docket No.: 00750455AA

Group Art Unit: 2823

Examiner: William D. COLEMAN

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7/11/03
JLM

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AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

In response to the Office Action mailed April 7, 2003, Applicants submit the following Remarks.

Applicants believe that no extensions of time or fees for net addition of claims are required at this time. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. §1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No.09-0458.